

Docket No.: 0553-0381

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shunpei YAMAZAKI et al.)
Application No.: 10/706,604) Examiner: Unknown
Filed: November 10, 2003) Group Art Unit:
For: MANUFACTURING METHOD OF EMITTING DEVICE) Not Yet Assigned

VERIFICATION OF TRANSLATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

I, Hiroshi Sunagawa, C/O Semiconductor Energy Laboratory Co., Ltd. 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan, herewith declare:

that I am well acquainted with both the Japanese and English Languages; and

that to the best of my knowledge and belief the followings is a true and correct translation of the US Patent Application No. 10/706,604 filed on November 10, 2003.

I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Date: this 22th day of July

Name: Hiroshi Sunagawa